

Appl. No. 09/754,277
Amendment and/or Response
Reply to Office Action of December 24, 2003

OFFICIAL

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IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

Appl. No.: 09/754,277
Applicant(s): T. Sawayana
Filed: January 5, 2001
TC/A.U.: 1700/1763
Examiner: L. Alejandro Mulero
Atty. Docket: Oki.201
Title: Plasma Etching Apparatus

CERTIFICATE OF MAILING OR
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On: May 24, 2004

By: 
William S. Francos

AMENDMENT and/or RESPONSE UNDER 37 CFR 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of December 24, 2003,
please amend the above referenced application as follows and
reconsider the application in light of the following remarks.

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This paper includes (each beginning on a separate sheet):

- 1. Amendments to the Claims, reflected in the complete listing of the claims, which begins on page 3 of this paper;**
- 2. Remarks/Discussion of issues, which begin on page 6 of this paper;**

Atty. Docket No. OKI.201